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**** CONTINUING DATA *******

This application is a 371 of PCT/JP03/15128 11/27/2003 *dr*

**** FOREIGN APPLICATIONS *******

JAPAN 2002-343199 11/27/2002
 JAPAN 2003-000331 01/06/2003
 JAPAN 2003-029477 02/06/2003
 JAPAN 2003-064653 03/11/2003 *dr*

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 4	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>dr</i> Examiner's Signature	<i>dr</i> Initials			

ADDRESS

20995

TITLE

Polishing pad and method for manufacturing semiconductor device

FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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